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## IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF

: EXAMINER: MACARTHUR, S. R. SHOSUKE ENDOH, ET AL.

SERIAL NO: 10/751,898

: GROUP ART UNIT: 1716 FILED: JANUARY 7, 2004

FOR: PLASMA PROCESSING

APPARATUS AND FOCUS RING

## STATEMENT OF SUBSTANCE OF INTERVIEW

COMMISSIONER FOR PATENTS ALEXANDRIA, VIRGINIA 22313

SIR:

A personal interview was conducted with Examiner MacArthur on July 15, 2010. During the personal interview, Applicant's representative provided Examiner MacArthur with copies of Orthokinetics, Inc. v. Safety Travel Chairs, Inc., 806 F.2d 1565 and In re Stencel, 4 USPQ2d 1071. Applicant's representative explained that the features in the pending claims relating to the substrate by reference were not indefinite and should be given patentable weight in light of the above-noted case law. In combination with the interview summary provided by Examiner MacArthur, Applicants respectfully submit that the comments above substantially summarize the content of the personal interview conducted on July 15, 2010, in accordance with MPEP § 713.04.

Respectfully submitted,

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